	Application No.	No. Applicant(s)	
Notice of Allowability	10/749,497	CHU ET AL.	
	Examiner	Art Unit	
	William C. Choi	2873	
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate commu GHTS. This application is s	this application. If not include inication will be mailed in due	ed course. <b>THIS</b>
1. This communication is responsive to			
2. The allowed claim(s) is/are <u>1-13</u> .			
3. The drawings filed on are accepted by the Examiner.			
<ul> <li>4. Acknowledgment is made of a claim for foreign priority una)</li> <li>All b) Some* c) None of the:</li> <li>1. Certified copies of the priority documents have</li> <li>2. Certified copies of the priority documents have</li> <li>3. Copies of the certified copies of the priority documents have</li> <li>International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul>	been received been received in Applicatio	n No	ion from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file ENT of this application.	a reply complying with the rec	uirements
5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.			
<ol> <li>CORRECTED DRAWINGS (as "replacement sheets") mus</li> <li>(a) ☐ including changes required by the Notice of Draftspers</li> <li>1) ☐ hereto or 2) ☐ to Paper No./Mail Date</li> <li>(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date</li> </ol>	on's Patent Drawing Review		
Identifying indicia such as the application number (see 37 CFR 1, each sheet. Replacement sheet(s) should be labeled as such in t	84(c)) should be written on the header according to 37 CF	e drawings in the front (not the R 1.121(d).	back) of
7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.			
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Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. ☐ Notice of Inf	ormal Patent Application (PTC	D-152)
2. ☑ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. 🔲 Interview Su	ımmary (PTO-413),	· · · - /
3. ⊠ Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No./l 8), 7. ☐ Examiner's	Mail Date Amendment/Comment	
Paper No./Mail Date 1203 4.  Examiner's Comment Regarding Requirement for Deposit		Statement of Reasons for Allo	wanco
of Biological Material	9 Other		wallo
Georgia Ford Georgia Framiner Supervisory Rate of Examiner Technology Center 2800			

**Art Unit: 2873** 

Allowed Claims: 1-13.

## **REASONS FOR ALLOWANCE**

The following is an examiner's statement of reasons for allowance: none of the prior art either alone or in combination disclose or teach of the claimed combination of limitations to warrant a rejection under 35 USC 102 or 103.

Specifically, with respect to independent claim 1, none of the prior art alone or in combination disclose or teach of a method of operating a digital micromirror device comprising applying a reset voltage pulse to the micromirror and applying an offset voltage to the micromirror immediately after the reset voltage pulse as claimed, specifically comprising applying a damping pulse to the micromirror immediately after the offset voltage and reapplying the offset voltage to the micromirror, whereby the damping pulse reduces oscillation of the micromirror about a neutral position.

Specifically, with respect to independent claim 9, none of the prior art alone or in combination disclose or teach of a method of operating a digital micromirror device comprising applying a reset voltage pulse to the micromirror and applying an offset voltage to the micromirror immediately after the reset voltage pulse as claimed, specifically comprising applying a damping pulse to the micromirror immediately after the offset voltage and reapplying the offset voltage to the micromirror, whereby the damping pulse reduces oscillation of the micromirror about a neutral position and whose voltage is the same as the reset voltage.

## CITATION OF RELEVANT PRIOR ART

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Gale, Jr. (U.S. 5,285,196) is being cited herein to show a method of operating a digital micromirror device comprising some of the steps of the claimed invention, but does not specifically disclose the applying a damping pulse to the micromirror immediately after the offset voltage and reapplying the offset voltage to the micromirror, whereby the damping pulse reduces oscillation of the micromirror about a neutral position.

## CONCLUSION

Any inquiry concerning this communication or earlier communications from the examiner should be directed to William C. Choi whose telephone number is (571) 272-2324. The examiner can normally be reached on Monday-Friday from about 9:00 am to 6 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Georgia Y. Epps can be reached on (571) 272-2328. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only.

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For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

William Choi Patent Examiner Art Unit 2873 September 29, 2004

Georgik-Epps
Supervisory Patent Examiner
Technology Center 2800